Search Notes



Application/Control No.	Applicant(s)/Patent Under Reexamination	
10790213	TABATA, SEIICHIRO	
Examiner	Art Unit	
Liu, Li	2613	

SEARCHED					
Class	Subclass	Date	Examiner		
398	42, 135-139,	11/13-11/17, 2006	LL		
385	31-37, 92, 93, 14	11/13-11/17, 2006	LL		
359	569, 565	11/13-11/17, 2006	LL		
369	112	11/13-11/17, 2006	LL		

SEARCH NOTES				
Search Notes	Date	Examiner		
EAST: US-PGPUB, USPAT, EPO, JPO, DERWENT, IBM_TDB	11/13-11/17, 2006, 6/4/2007	LL		
GOOGLE	11/13-11/17, 2006	LL		
IEEE	11/13-11/17, - 2006	LL		
INSPECT, OpticsInfoBase, SPIE Digital Library	11/13-11/17, 2006	LL		

INTERFERENCE SEARCH					
Class	Subclass	Date	Examine		